

P21288.A01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Motohiro YAMASHITA

Serial No : Not Yet Assigned

Filed : Concurrently Herewith

For : VACUUM CONTAINER AND DISPLAY DEVICE

PRELIMINARY AMENDMENT

Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

Prior to the examination of the above-identified patent application on the merits, the Examiner is respectfully requested to amend the specification as follows:

IN THE SPECIFICATION

Please amend the BRIEF DESCRIPTION OF THE DRAWINGS beginning at page 14, line 9 of specification as follows (a marked-up copy of the amendments is provided as an attachment to this Amendment):

(Amended Specification-Clean Text)

BRIEF DESCRIPTION OF THE DRAWINGS

Fig. 1 is a cross sectional view of a display device according to Embodiment 1 of the present invention;

P21288.A01

Figs. 2A and 2B are cross sectional views of an electron emitter substrate;

Figs. 3A and 3B are cross sectional views of the display device according to Embodiment 1 of the present invention;

Figs 4A and 4B are schematic views of a control plate member in Embodiment 2 of the present invention;

Fig. 5 is a cross sectional view of a display device according to Embodiment 2 of the present invention;

Figs. 6A, 6B and 6C are longitudinally cross sectional views of the controlling member showing the vertex and the center of a base of a conical shape;

Fig. 7 is an explanatory view showing an arrangement of getter supports in Embodiment 2 of the present invention;

Figs. 8A, 8B, and 8C are views showing a procedure of fabricating the getter support;

Figs. 9A, 9B, and 9C are views showing another procedure of fabricating the getter support;

Figs. 10A, 10B, and 10C are views showing a further procedure of fabricating the getter support;

Fig. 11 is a cross sectional view of a conventional vacuum container; and

Fig. 12 illustrates a plan view and a cross sectional view of an evaporation-type getter.

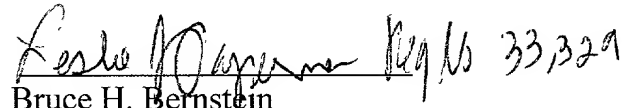
P21288.A01

REMARKS

By the above amendment, the specification has been amended to more accurately describe the figures.

If there should be any questions, the Examiner is invited to contact the undersigned at the telephone number listed below.

Respectfully submitted,
Motohiro YAMASHITA


Bruce H. Bernstein
Reg. No. 29,027

July 23, 2001
GREENBLUM & BERNSTEIN, P.L.C.
1941 Roland Clarke Place
Reston, VA 20191
(703) 716-1191

MARKED-UP COPY OF AMENDMENTS TO THE SPECIFICATION

BRIEF DESCRIPTION OF THE DRAWINGS

Fig. 1 is a cross sectional view of a display device according to Embodiment 1 of the present invention;

[Fig. 2 is a cross sectional view] Figs. 2A and 2B are cross sectional views of an electron emitter substrate;

[Fig. 3 is a cross sectional view] Figs. 3A and 3B are cross sectional views of the display device according to Embodiment 1 of the present invention;

[Fig. 4 is a schematic view] Figs 4A and 4B are schematic views of a control plate member in Embodiment 2 of the present invention;

Fig. 5 is a cross sectional view of a display device according to Embodiment 2 of the present invention;

[Fig. 6 is a longitudinally cross sectional view] Figs. 6A, 6B and 6C are longitudinally cross sectional views of the controlling member showing the vertex and the center of a base of a conical shape;

Fig. 7 is an explanatory view showing an arrangement of getter supports in Embodiment 2 of the present invention;

[Fig. 8 is a view] Figs. 8A, 8B, and 8C are views showing a procedure of fabricating the getter support;

P21288.A01

[Fig. 9 is a view] Figs. 9A, 9B, and 9C are views showing another procedure of fabricating the getter support;

[Fig. 10 is a view] Figs. 10A, 10B, and 10C are views showing a further procedure of fabricating the getter support;

Fig. 11 is a cross sectional view of a conventional vacuum container; and

Fig. 12 illustrates a plan view and a cross sectional view of a evaporation-type getter.